

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**OFFICIAL****In re United States Patent Application of:****Applicant:** Peter Van Buskirk, et al.**Application No.:** 09/200,495**Date Filed:** November 25, 1998**Title:** OXIDATIVE TOP
ELECTRODE DEPOSITION
PROCESS, AND
MICROELECTRONIC
DEVICE STRUCTURE**Customer No.:** 25559**Docket No.:** 2771-337 RCE 2**Examiner:** S. Hu**Art Group:** 2811**Confirmation
No.:** 4898**RECEIVED
CENTRAL FAX CENTER****MAR 23 2004****FACSIMILE TRANSMISSION CERTIFICATE****ATTN: Examiner Hu
Fax No. (703) 872-9306**

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Commissioner for Patents, Mail Stop AF, PO Box 1450, Alexandria, VA 22313-1450, on March 23, 2004 to United States Patent and Trademark Office facsimile transmission number (703) 872-9306.

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Number of Pages (including cover)


Marianne Fuierer

March 23, 2004

Date

**RESPONSE TO JANUARY 23, 2004 OFFICE ACTION
IN U.S. PATENT APPLICATION NO. 09/200,495**

Mail Stop AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 23, 2004, in the above-identified patent application, please amend the application as follows: